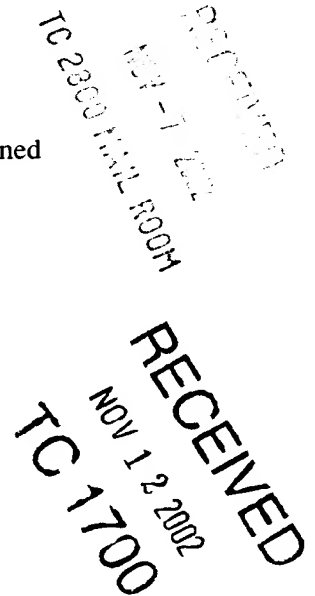


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of  
Robert J. O'DONNELL et al.  
Application No.: 09/820,693  
Filed: March 30, 2001

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)  
) Group Art Unit: 2812  
)  
) Examiner: Not Yet Assigned  
)  
) Confirmation No.: 5643  
)  
)  
)

For: CERIUM OXIDE CONTAINING  
CERAMIC COMPONENTS AND  
COATINGS IN SEMICONDUCTOR  
PROCESSING EQUIPMENT AND  
METHODS OF MANUFACTURE  
THEREOF



INFORMATION DISCLOSURE STATEMENT  
TRANSMITTAL LETTER

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

Enclosed is an Information Disclosure Statement and accompanying form PTO-1449 for the above-identified patent application.

- ☒ [X] No additional fee for submission of an IDS is required.
- ☐ [ ] The fee of \$180.00 (126) as set forth in 37 C.F.R. § 1.17(p) is also enclosed.
- ☐ [ ] A certification under 37 C.F.R. § 1.97(e) is also enclosed.
- ☐ [ ] A certification under 37 C.F.R. § 1.97(e), and the fee of \$180.00 (126) as set forth in 37 C.F.R. § 1.17(p) are also enclosed.
- ☐ [ ] Charge \$\_\_\_\_\_ to Deposit Account No. 02-4800 for the fee due.
- ☐ [ ] A check in the amount of \$\_\_\_\_\_ is enclosed for the fee due.

The Commissioner is hereby authorized to charge any appropriate fees under 37 C.F.R. §§ 1.16, 1.17 and 1.21 that may be required by this paper, and to credit any overpayment, to Deposit Account No. 02-4800. This paper is submitted in duplicate.

Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS, L.L.P.

P.O. Box 1404  
Alexandria, Virginia 22313-1404  
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By: Peter K. Skiff  
Peter K. Skiff  
Registration No. 31,917

Date: November 6, 2002



Patent  
Attorney's Docket No. 015290-509

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of	)	
	)	
Robert J. O'DONNELL et al.	)	Group Art Unit: 2812
	)	
Application No.: 09/820,693	)	Examiner: Not Yet Assigned
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Filed: March 30, 2001	)	Confirmation No.: 5643
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For: CERIUM OXIDE CONTAINING	)	
CERAMIC COMPONENTS AND	)	
COATINGS IN SEMICONDUCTOR	)	
PROCESSING EQUIPMENT AND	)	
METHODS OF MANUFACTURE	)	
THEREOF	)	

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**INFORMATION DISCLOSURE STATEMENT**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. § 1.56, Applicants hereby submit a Written Opinion dated October 21, 2002 for a corresponding application. Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents cited in the Written Opinion but not of record in the present application is enclosed.

Written Opinion dated October 21, 2002 for PCT/US02/06651.

I, the undersigned, hereby state that each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart application and that this communication was not received by any individual designated in § 1.56(c) more than 30 (thirty) days prior to the filing of this Information Disclosure Statement.

To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS, L.L.P.

By: Peter K. Skiff  
Peter K. Skiff  
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